FIG.1

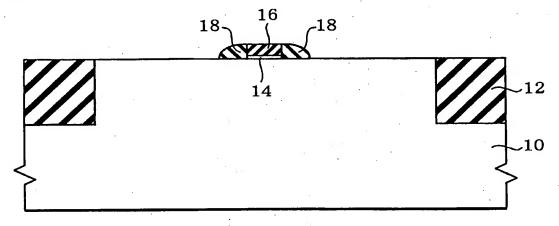


FIG.2

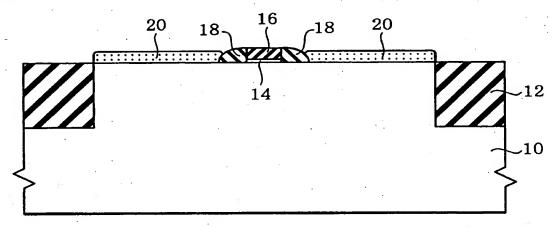
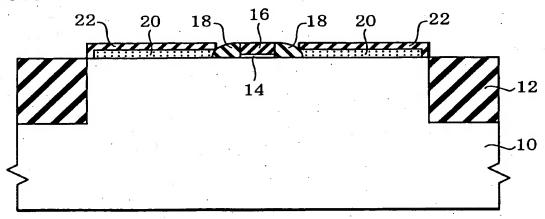


FIG.3



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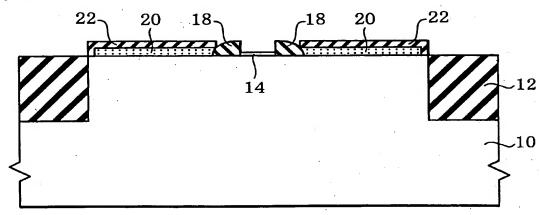


FIG.5

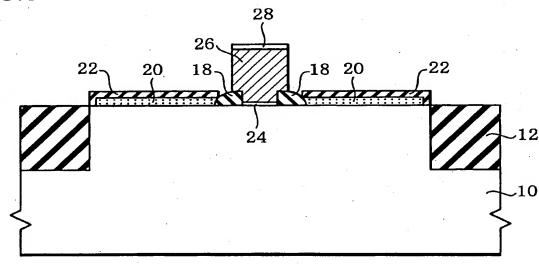


FIG.6

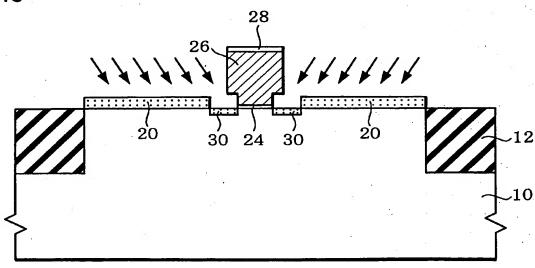


FIG.7

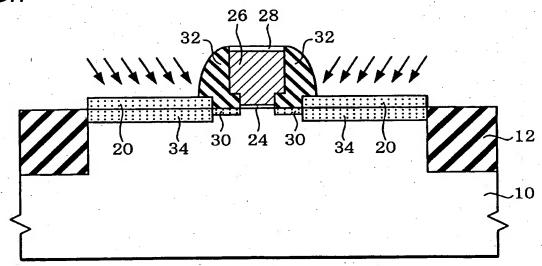


FIG.8

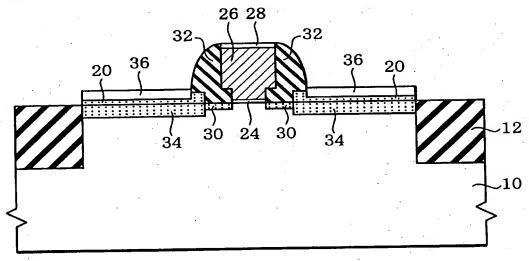


FIG.9

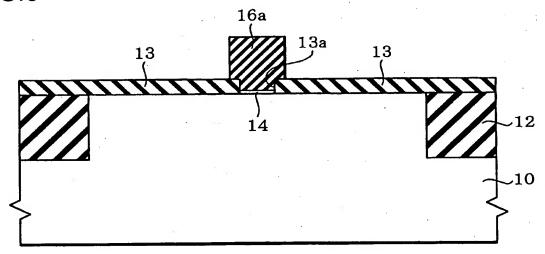


FIG.10

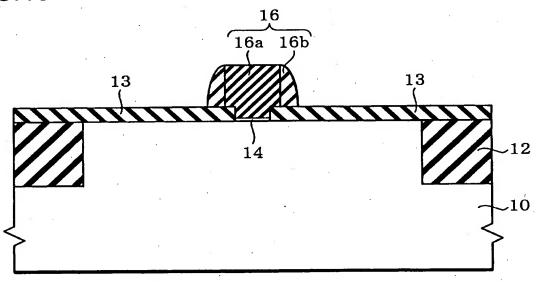


FIG.11

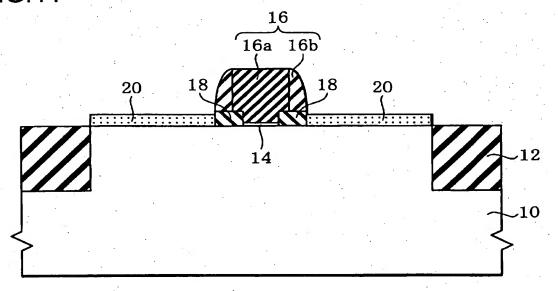


FIG.12

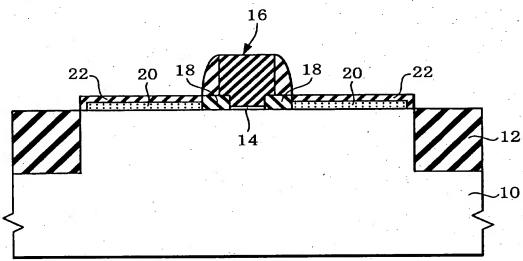


FIG.13

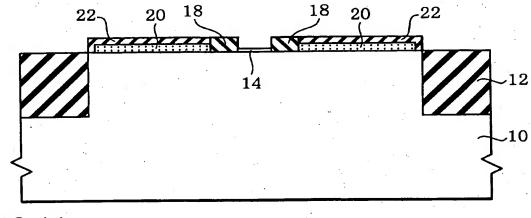


FIG.14

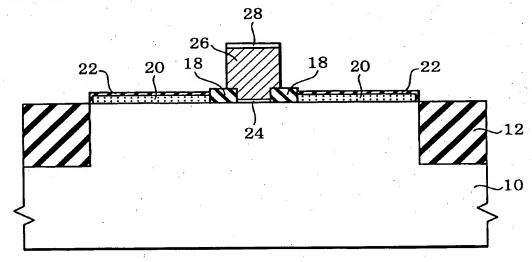
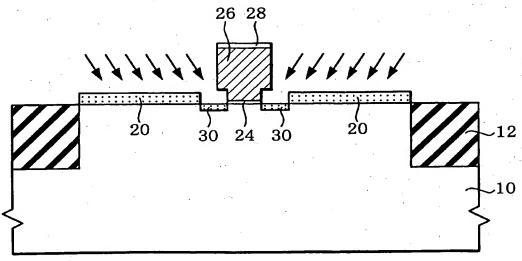


FIG.15



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FIG.16

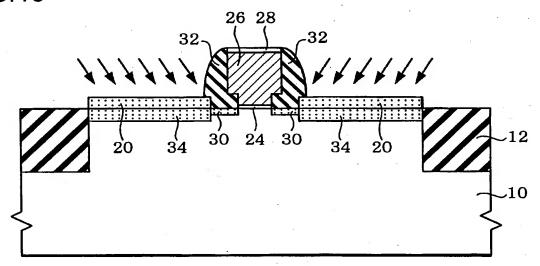


FIG.17

